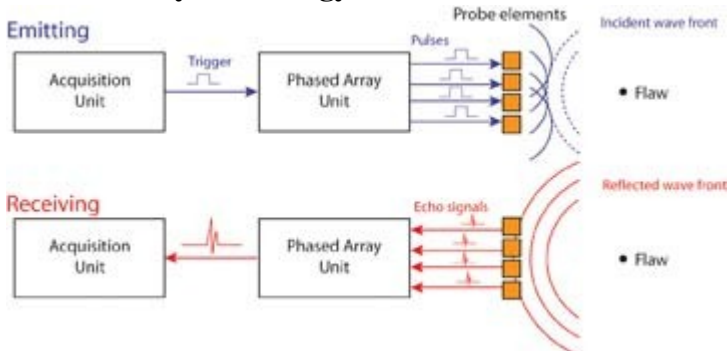


OmniScan MX PA



Phased Array Inspection

Phased Array Technology



Phased array technology generates an ultrasonic beam with the capability of setting beam parameters such as angle, focal distance, and focal point size through software. Furthermore, this beam can be multiplexed over a large array. These capabilities open a series of new possibilities. For instance, it is possible to quickly vary the angle of the beam to scan a part without moving the probe itself. Phased arrays also allow the replacement of multiple probes and even mechanical components. Inspecting a part with a variable-angle beam also maximizes detection regardless of the defect orientation, while optimizing signal-to-noise ratio.

Benefits of Phased Arrays

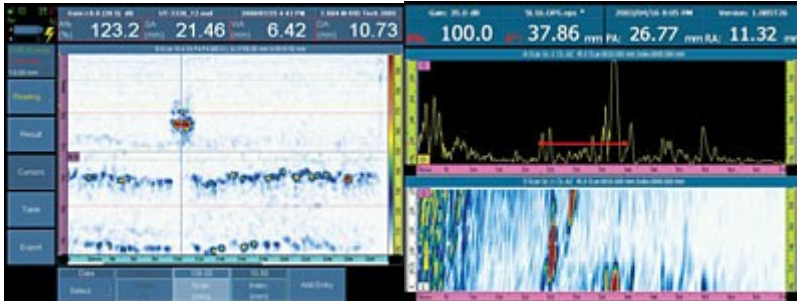
Phased array technology offers the following capabilities:

- Software control of beam angle, focal distance, and spot size
- Multiple-angle inspection with a single, small, electronically-controlled multielement probe
- Greater flexibility for the inspection of complex geometry

- High-speed scans with no moving parts

Phased Array Software

Full-Featured A-Scan, B-Scan, and C-Scans



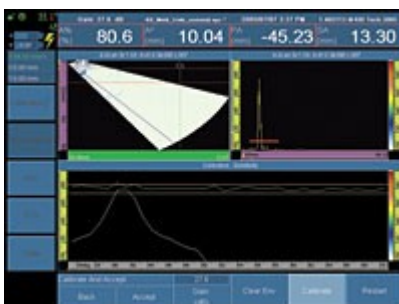
OmniScan PA builds upon the OmniScan UT feature set and offers full-featured A-, B-, and C-scan displays.

Full-Featured Sectorial Scan



- Real-time volume-corrected representation
- Higher than 20 Hz refresh rate (up to 40 Hz)

Advanced Real-Time Data Processing



- Real-time data interpolation to improve spatial representation of defects during acquisition of data
- User-selectable high- and low-pass filters to enhance A-scan and imaging quality
- Projection feature allows the operator to view vertically positioned A-scan simultaneously with sectorial scan image.

Calibration Procedures and Parameters

All calibration procedures are guided by a step-by-step menu using Next and Back navigation.

Wizards for Groups and Focal Laws

- The Group Wizard allows you to enter all probe, part, and beam parameters, and generate all focal laws in one step instead of generating them with each change.
- The step-by-step approach prevents the user from missing a parameter change.
- Online help gives general information on parameters to be set.

Multiple-Group Option

It is now possible to manage more than one probe with two different configurations: different skews, different scanning types, different inspection areas, and other parameters.

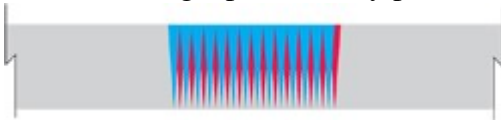
Possible Configurations for Multiple-Group Inspection

A Use one single phased array probe of 64 or more elements and create 2 different groups:



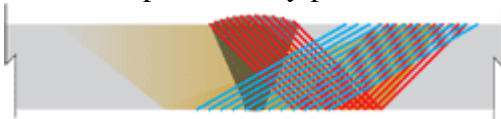
- Linear scan at 45° to cover the upper part using skips on the bottom surface
- Linear scan at 60° to cover the lower part

B Use one single phased array probe of 64 or 128 elements and create 2 different groups



- Linear scan at 0° at low gain
- Linear scan at 0° at higher gain

C Use one phased array probe of 64 or 128 elements and create 3 different groups:



- Linear scan at 45° to cover the upper part using skips on the bottom surface
- Linear scan at 60° to cover the lower part
- Sectorial scan from 35° to 70° to increase probability of detection

D Use two phased array probes of 16 or 64 elements and create 2 different groups:



- Sectorial scan from 35° to 70° for inspection from left side of the part using skips on the bottom surface
- Sectorial scan from 35° to 70° for inspection from right side of the part using skips on the bottom surface

Phased Array Module Specifications*

Overall dimensions	244 mm x 182 mm x 57 mm (9.6 in. x 7.1 in. x 2.1 in.)
Weight	1 kg (2.2 lb)
Connectors	1 OmniScan connector for phased-array probes 2 BNC connectors (1 pulser/receiver, 1 receiver for conventional UT) (BNC not available on models 32:128)
Number of focal laws	256
Probe recognition	Automatic probe recognition and setup
Pulser/Receiver	
Aperture	16 elements*
Number of elements	128 elements
Pulser	
Voltage	80 V per element
Pulse width	Adjustable from 30 ns to 500 ns, resolution of 2.5 ns
Fall time	Less than 10 ns
Pulse shape	Negative square wave
Output impedance	Less than 25 Ω
Receiver	
Gain	0-74 dB maximum input signal 1.32 V p-p
Input impedance	75 Ω
System bandwidth	0.75-18 MHz (-3 dB)
Beam forming	
Scan type	Azimuthal and linear
Scan quantity	Up to 8
Active elements	16*
Elements	128

Delay range transmission 0-10 μ s in 2.5-ns increments

Delay range reception 0-10 μ s in 2.5-ns increments

Data acquisition

Digitizing frequency 100 MHz (10 bits)

Maximum pulsing rate Up to 10 kHz (C-scan)

Acquisition depth 29 meters in steel (L-wave), 10 ms with compression. 0.24 meter in steel (L-wave), 81.9 μ s without compression

Data processing

Number of data points Up to 8000

Real-time averaging 2, 4, 8, 16

Rectifier RF, full wave, halfwave +, halfwave -

Filtering Low-pass (adjusted to probe frequency), digital filtering (bandwidth, frequency range)

Video filtering Smoothing (adjusted to probe frequency range)

Data storage

A-scan recording (TOFD) 6000 A-scans per second (512-point 8-bit A-scan)

C-scan type data recording I, A, B, up to 10 kHz (amplitude or TOF)

Maximum file size Limited by memory size

Data visualization

A-scan refresh rate Real-time: 60 Hz

Volume-corrected S-scan Up to 40 Hz

Data synchronization

On time 1 HZ-10 kHz

On encoder On 1 or 2 axes

Programmable time-corrected gain (TCG)

Number of points 16 (1 TCG curve per channel for focal laws)

Alarms

Number of alarms 3

Conditions Any logical combination of gates

Analog outputs 2